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FACSIMILE COVER LETTER

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Art Unit 2815

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Serial No:

10/752,642

Number of Pages: (including cover page)

9

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PATENT 790001-2042

U.S. Application No. 10/752,642 Supplemental Amendment

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s)

Naofumi Nakamura et al.

Serial No.

10/752,642

For

SEMICONDUCTOR DEVICE AND METHOD OF

FABRICATING THE SAME

Filing Date

January 7, 2004

Examiner

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SUPPLEMENTAL AMENDMENT

MAIL STOP AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that the above-identified application be amended as follows.

U.S. Application No. 10/752,642 Supplemental Amendment PATENT 790001-2042

Amendments to the Claims are reflected in the listing of claims, which begins on page 3 of this paper.

Remarks/Arguments begin on page 7 of this paper.